

SEP 05 2006

**REPLY UNDER 37 C.F.R. § 1.116 – EXPEDITED PROCEDURE –
TECHNOLOGY CENTER 2800**PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Peter D. BREWER) Examiner: Thanhha S. Pham
)
Serial No.: 10/787,276) Art Unit: 2813
)
Filed: February 25, 2004) Our Ref: B-4712 620052-7
)
For: "SELF-MASKING DEFECT REMOVING METHOD") Date: September 5, 2006
)
) Re: <i>Amendment and response</i>

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The Applicant submits an amendment and reply pursuant to 37 CF.R. § 1.116 in response to the final Office Action mailed on July 3, 2006, a response to which is initially to be filed, without extension of time, no later than

October 3, 2006.

U. S. Appl'n. No. 10/787,276

**Reply under 37 CFR 1.116 - Expedited Procedure –
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Please amend the above-identified application as described below and consider the following remarks. All remarks and amendments herein are made without prejudice.

Proposed amendments to the Claims are listed beginning on page 3 of this paper.

Remarks begin on page 6 of this paper.